

CLAIMS

1. A method for forming a back plate for a display composing the steps of:
forming an indium tin oxide (ITO) layer on a substrate;
patterning the ITO layer with resist material to form etch protected areas to define electrode lines;
etch the ITO in areas are protected by etch resist; and
forming light separating material in recesses between electrode lines.
2. A method of forming a faceplate for a display, composing the steps of:
forming light separating material in a substrate to define color filter lines;
forming color filter in areas between the light separating material with each color filters having a height greater than the light separating material;
forming an indium tin oxide (ITO) layer over the color filters and light separating material;
placing etch-resist on the color filters;
etch the ITO from the recesses between the color filter over the light separating material.